

Reply under 37 CFR 1.116
Expedited Procedure
Technology Center 2800

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Application Serial No	
	3193
	August 30, 2001
	Eugene P. Marsh
	Micron Technology, Inc.
Examiner	G. Fourson
Attorney's Docket No	MI22-1728
•	
Title: Dielectric Material Forming Methods and Enhanced Dielectric Methods	

RESPONSE TO JUNE 16, 2006 FINAL OFFICE ACTION

· To:

MS AF

Commissioner for Patents

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AMENDMENTS

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